

PRIOR ART

FIG. 2

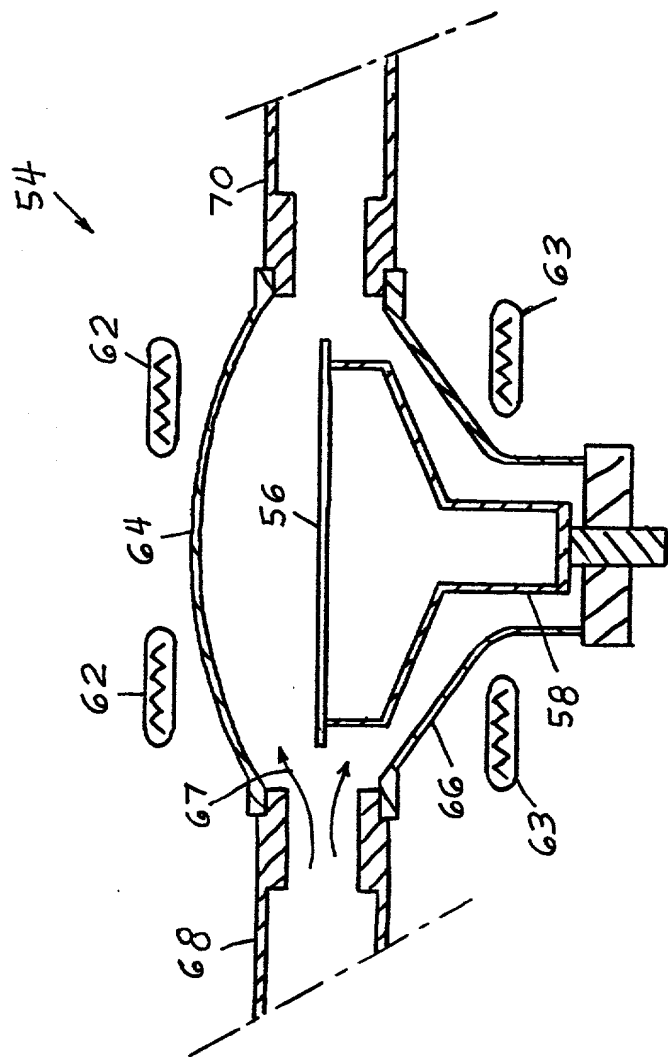


FIG. 3

PRIOR ART

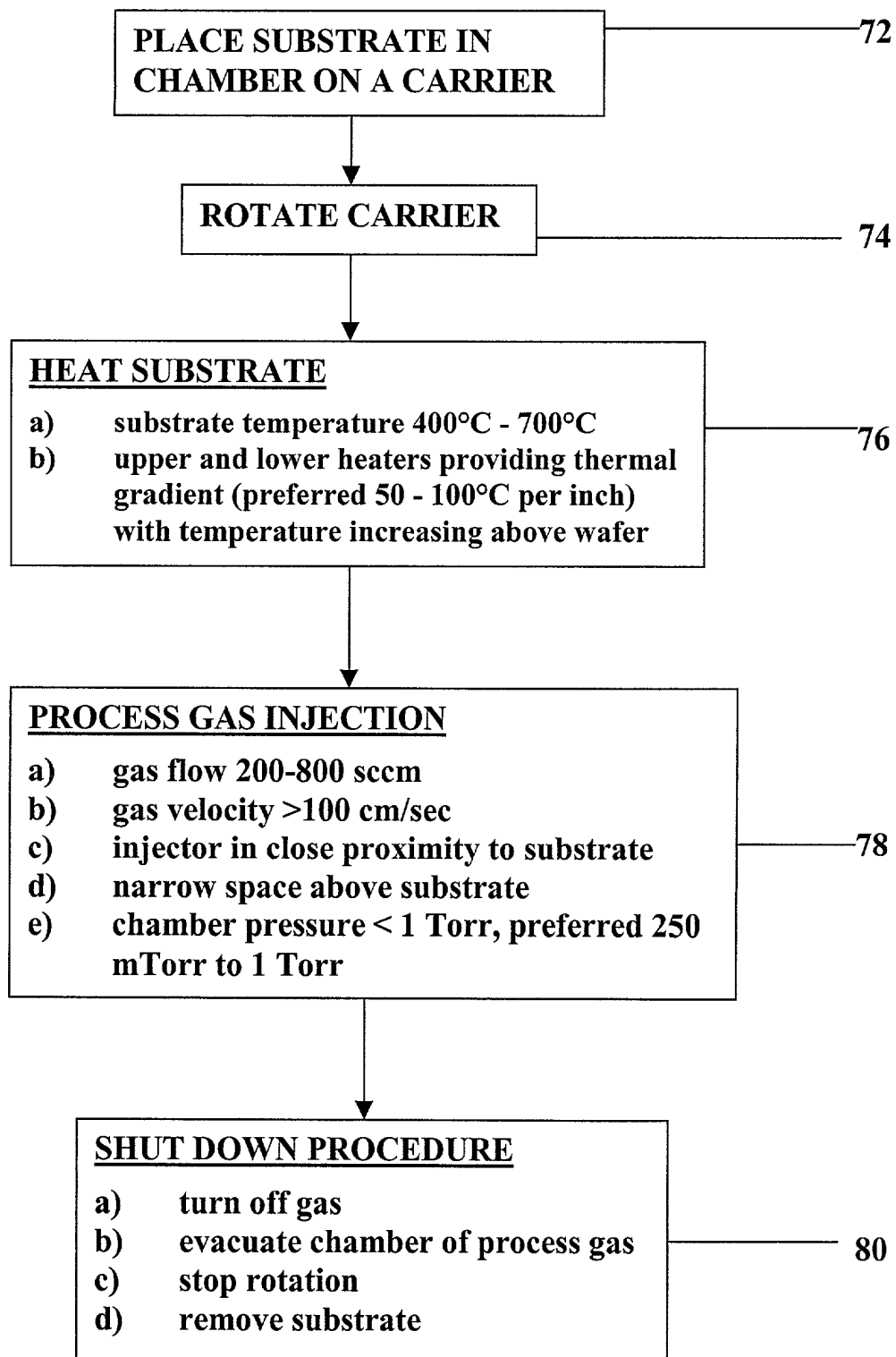


FIG. 4

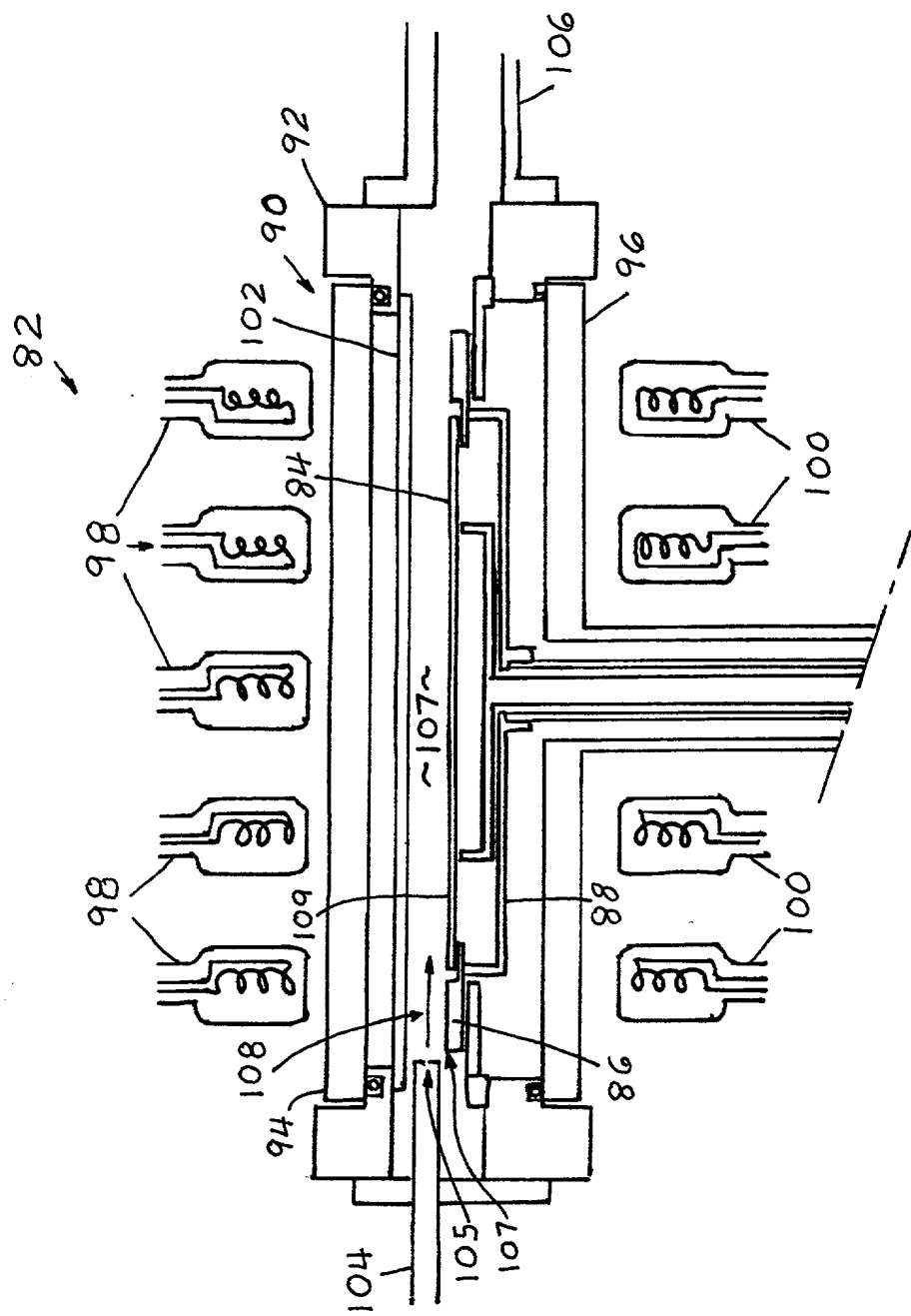


FIG 5

Deposition Rate vs Temperature

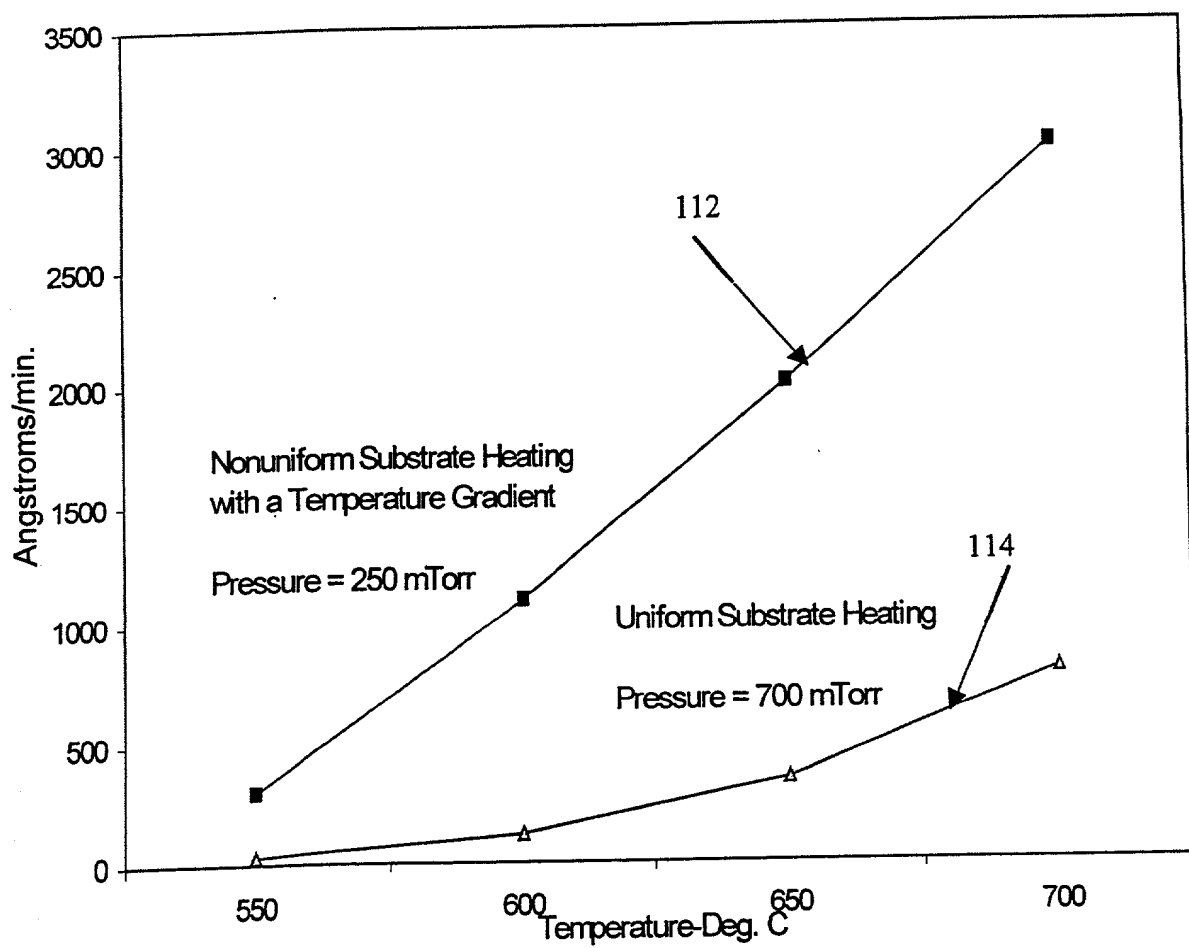


Figure 6

Silicon Deposition Rate vs Silane Flow
with Non-uniform Substrate Heating

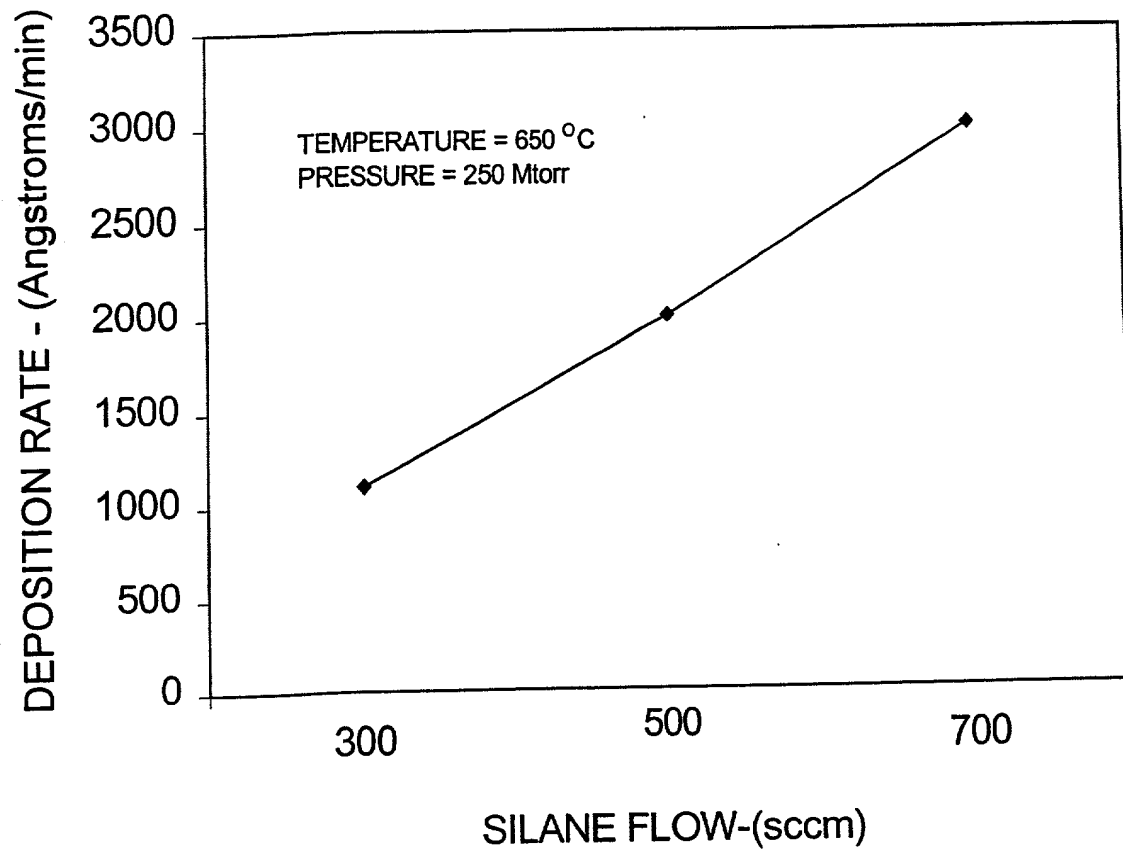


Figure 7

Silicon Nitride Deposition Rate versus Silane Flow

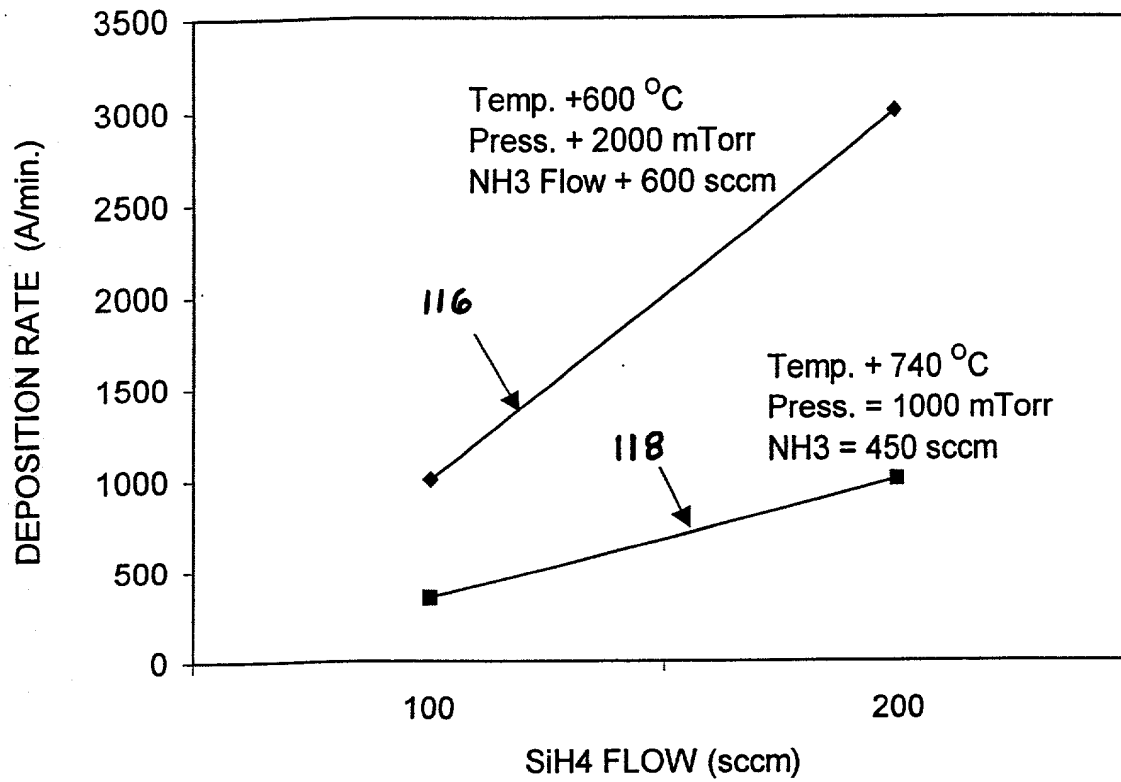


Figure 8

Silicon Nitride Deposition Rate versus Pressure

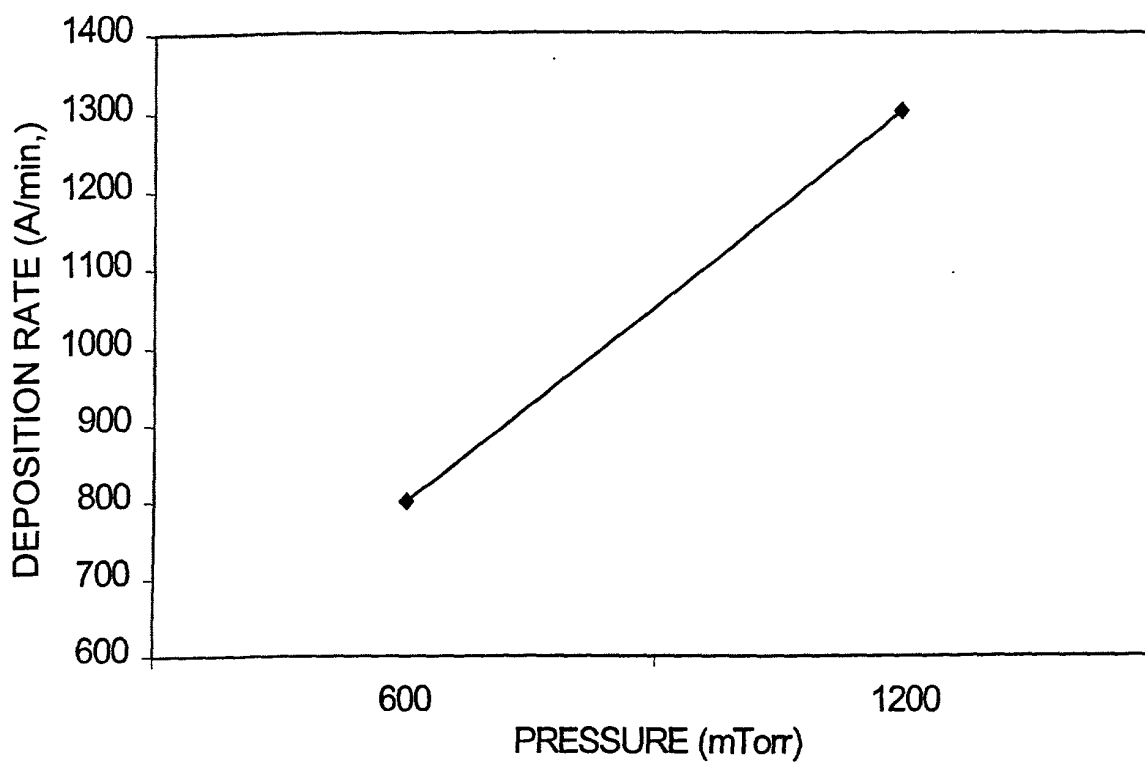


Figure 9